

## Electronic Patent Application Fee Transmittal

<b>Application Number:</b>	10804053				
<b>Filing Date:</b>	19-Mar-2004				
<b>Title of Invention:</b>	Film formation method and manufacturing method of semiconductor device				
<b>First Named Inventor/Applicant Name:</b>	Mitsuhiro Ichijo				
<b>Filer:</b>	Carlos Rafael Villamar/Kisha Avery				
<b>Attorney Docket Number:</b>	740756-2718				
Filed as Large Entity					
<b>Utility Filing Fees</b>					
<b>Description</b>		<b>Fee Code</b>	<b>Quantity</b>	<b>Amount</b>	<b>Sub-Total in USD(\$)</b>
<b>Basic Filing:</b>					
<b>Pages:</b>					
<b>Claims:</b>					
<b>Miscellaneous-Filing:</b>					
<b>Petition:</b>					
<b>Patent-Appeals-and-Interference:</b>					
<b>Post-Allowance-and-Post-Issuance:</b>					
<b>Extension-of-Time:</b>					
Extension - 2 months with \$0 paid		1252	1	450	450

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Miscellaneous:</b>				
Request for continued examination	1801	1	790	790
<b>Total in USD (\$)</b>				<b>1240</b>